



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Miwa KOZAWA, et al.**

Group Art Unit: **Not yet assigned**

Serial No.: **10/629,806**

Examiner: **Not yet assigned**

Filed: **July 30, 2003**

P.T.O. Confirmation No.: **Not yet assigned**

For: **RESIST PATTERN THICKENING MATERIAL, PROCESS FOR
FORMING RESIST PATTERN, AND PROCESS FOR
MANUFACTURING SEMICONDUCTOR DEVICE**

INFORMATION DISCLOSURE STATEMENT
PURSUANT TO 37 CFR 1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Date: November 18, 2003

Sir:

The attention of the Patent and Trademark Office is hereby directed to the document listed on the attached Form PTO-1449. A copy of the document is attached.

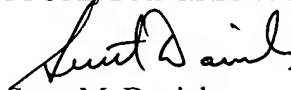
No fee or certification is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 50-2866 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

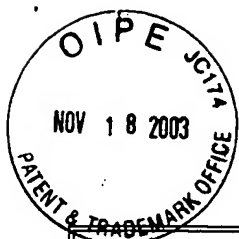


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PATENT TRADEMARK OFFICE

Enclosures: Form PTO-1449
6 References



INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 030923	Serial No. 10/629,806
	Applicant(s) Miwa KOZAWA, et al.	
	Filing Date: July 30, 2003	Group Art Unit: Not yet assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA					
	AB					
	AC					
	AD					
	AE					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
AF	10-73927	03/17/1998	Japan	Yes (Abstract only)
AG	5-197151	08/06/1993	Japan	Yes
AH	2000-347414	12/15/2000	Japan	Yes
AI	2001-228616	08/24/2001	Japan	Yes
AJ	2002-6491	01/09/2002	Japan	Yes
AK	2002-49161	02/15/2002	Japan	Yes

OTHER DOCUMENTS

	AL	
	AM	
Examiner	Date Considered	